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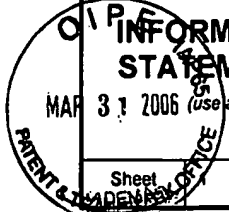
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/625,737
		Filing Date	July 24, 2003
		First Named Inventor	Koji DAIRIKI
		Group Art Unit	2822
		Examiner Name	Maria Guerrero
Sheet 3 of 1	Attorney Docket Number	0756-7176	



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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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Examiner Signature	Maria Guerrero	Date Considered	6-2-06
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